



- Core Measurements
- ⊳ CO
- ⊳ CO₂
- NOx
- SO₂
- D₂
- ▶ Flow
- Dust
- Optional Measurements
- ▶ Formaldehyde
- Ammonia
- ▶ Hydrogen Sulfide
- Methane
- ▶ Hydrogen Chloride
- ▶ Hydrogen Fluoride
- ▶ Others

Various concentration ranges available to meet your specific application



Ohio Lumex CEM Systems

► MEGA[™] Continuous Emissions Monitor (CEMS)

⊳ CO, CO₂, NOx, SO₂, O₂, Others

- Dust Monitors
- Flow Monitors
- ▶ Data Acquisition Systems (DAS)

Applications

- Power
- Cement
- Aluminum
- Fertilizer
- Biomass
- Ceramic
- Sugar
- Bio Diesel
- Ethanol

- Mining
- Metals
- ▶ Iron and Steel
- ▶ Refineries
- Waste Incinerator
- ▶ Pulp and Paper
- Gas Turbines
- Petrochemical
- ▶ Glass



CEMS Data Acquisition System









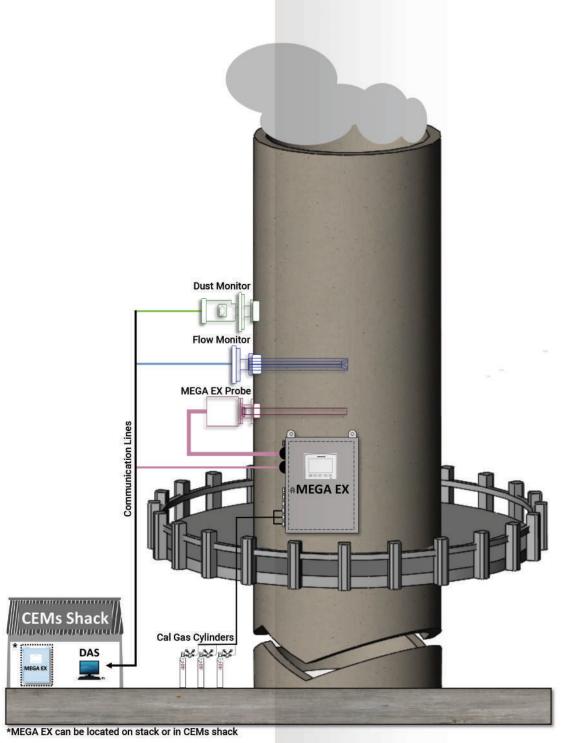
MEGA EX Multi-Component

Continuous Emissions Monitor

- Durable and Reliable Design
- ▶ Compact and Lightweight
- **▶** Measure Multiple Gases Simultaneously
- ▶ No Additional Instruments Needed
- ► Flexibility to Use Optimal Measurement Technology Depending on Application
- ▶ Non-Dispersive Infrared (NDIR)
- Ultra-Violet Differential Optical Absorption Spectroscopy (UV-DOAS)
- ▶ Chemiluminescence (CLD)
- ▶ Tunable Diode Laser (TDL)
- ▶ Electro-Chemical Devices (ECD)
- Optical Sensor
- Designed for Process Control and/or Emissions Monitoring
- **▶** Economical Solution
- ▶ Low Acquisition Cost
- ▶ Inexpensive to Operate
- ► Easy to Service and Maintain

Data Acquisition System (DAS)

- Integrated CEM Data Logger, Data Handling and Reporting System
- ▶ System Manager for Control Room
- ▶ Extensive Selection of CEMS Compliance and Data Reports
- ▶ Microsoft SQL Server, Access, or Oracle Database Compatible
- Data Exportable to Microsoft Excel Spreadsheets
- Data Editor, Edit Trail Program, QA Programs, Alarms, and Trend Display
- ▶ Voice Message and Email Alarms
- ▶ Remote Access and Real-Time Data Display
- Compliant with US EPA 40 CFR Part 60 and 75 Requirements



Dust Monitors

- ▶ Opacity and Dust Monitor
- Dynamic Detection Principle (DDP) Measurement
- Cross Stack / Duct
- ▶ Automatic Calibration
- Compliant with US EPA 40 CFR Part 60 and 75 Requirement
- Dust Monitor
- ▶ Laser Backscatter Principle

Flow Monitors

- Optical Scintillation
 - Cross Stack / Duct
 - ▶ Measures Path 90 Degrees to Stack
 - ▶ Second Platform Not Required
 - Unaffected by path length, media, pressure, moisture, and opacity
 - ▶ No Interferences
 - Automatic Calibration
- Compliant with US EPA 40 CFR Part 60 and 75 Requirement

Ultrasonic

Compliant with US EPA 40 CFR Part 60 and 75 Requirement

▶ Pitot Tube

